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## BIB DATA SHEET

CONFIRMATION NO. 6245

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/650,193	08/28/2003	257	2826	Q77191
<b>APPLICANTS</b> Koichi Ohto, Kanagawa, JAPAN; Toshiyuki Takewaki, Kanagawa, JAPAN; Tatsuya Usami, Kanagawa, JAPAN; Nobuyuki Yamanishi, Kanagawa, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a CIP of 10/281,321 10/28/2002 ABN				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-132780 05/08/2002 JAPAN 2002-302841 10/17/2002 JAPAN 2003-130484 05/05/2003				
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 11/28/2003				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/A O WILLIAMS/</u> Examiner's Signature	<input checked="" type="checkbox"/> Met after Allowance AW Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 87	<b>TOTAL CLAIMS</b> 212
<b>INDEPENDENT CLAIMS</b> 17				
<b>ADDRESS</b> SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037 UNITED STATES				
<b>TITLE</b> SINGLE DAMASCENE STRUCTURE SEMICONDUCTOR DEVICE HAVING SILICON-DIFFUSED METAL WIRING LAYER				
<b>FILING FEE RECEIVED</b> 5932	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	